



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatomo YAMAGUCHI et al.

Group Art Unit: 1792

Application No.: 10/574,568

Examiner: K. CHEN

Filed: August 7, 2006

Docket No.: 127569

For: SUBSTRATE PROCESSING APPARATUS, SUBSTRATE HOLDER, AND  
MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the January 16, 2008 Office Action, the period for reply being extended by  
the attached Petition for Extension of Time, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**